



1122.70096

PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant: Kenichi Shimazaki et al.

Serial No.: 10/807,497

Conf. No.: 3046

Filed: March 23, 2004

For: SYSTEM AND METHOD FOR)
DETERMINATION OF LOAD)
MONITORING CONDITION AND)
LOAD MONITORING PROGRAM)

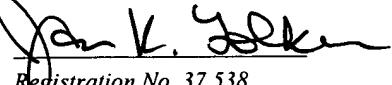
Art Unit: 2857

Examiner: Robbins, Janet L.

I hereby certify that this paper is being deposited with
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July 13, 2006

Date


Registration No. 37,538
Attorney for Applicant(s)

Mail Stop AF
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

In response to the Final Office Action dated April 4, 2006, please amend the
above-identified Application as follows: